

**Search Notes**

Application/Control No.

10/666,734

Examiner

John Rivell

Applicant(s)/Patent under  
Reexamination

KIM ET AL.

Art Unit

3753

**SEARCHED**

Class	Subclass	Date	Examiner
137	1 312 552	12/19/2005	
118	715	12/19/2005	
700	21 82 282	12/19/2005	

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
Interference Search History Printout		12/19/2005	

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST (US, USPGPub, USOCR, DERWENR, EPO, JPO, IBM Technical)	12/19/2005	